maye 2856

PTO/SB/21 (08-03)
Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

	17107 01 1000. 10 001001	Application Number	on of information unless it displays a valid QMB control number.		
			09/867,286		
TRANSMIT	IAL	Filing Date	May 29, 2001		
FORM		First Named Inventor	Robert Ried et al.		
(to be used for all correspondent	ce after initial filing)	Art Unit	2856; Confirmation No. 6239		
		Examiner Name	Helen C. Kwok		
Total Number of Domes in This Co	ıbmission 3	Attorney Docket Number	IO-1002US		
Total Number of Pages in This Su	JUMISSION   5				
	ENC	LOSURES (Check all tha	t apply)		
Fee Transmittal Form  Fee Attached  Amendment/Reply  After Final  Affidavits/declaration(s)  Extension of Time Request  Express Abandonment Request  Supplemental Information Disclosure Statement  Certified Copy of Priority Document(s)  Response to Missing Parts/ Incomplete Application  Response to Missing Parts under 37 CFR 1.52 or 1.53			After Allowance communication to Group  Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)  Proprietary Information  Status Letter Other Enclosure(s) (please Identify below): Postcard; seven (7) references  Athorized to charge any additional fees or posit Account No. 13-0010 (IO-1002US)		
	SIGNATURE (	OF APPLICANT, ATTORN	IEY, OR AGENT		
Firm or Individual name Todd A. I	Bynum, Reg. No				
Date March 10, 2004					
i i i i i i i i i i i i i i i i i i i			·		
	CERTIFIC	CATE OF TRANSMISSIO	N/MAILING		
			or deposited with the United States Postal Service with atents, P.O. Box 1450, Alexandria, VA 22313-1450 on		
Typed or printed name	th Pearson-Nau	ıl			
Signature Date March 10, 2004					

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PPLICANT: Robert Ried et al.

Group Art Unit: 2856

SERIAL NO.: 09/867,286

 $\omega$ 

Examiner: Helen C. Kwok

FILED: May 29, 2001

Confirmation No.: 6239

TITLE: "Accelerometer with Re-Entrant

Grooves"

Atty Docket No.: IO-1002US

Commissioner for Patents P. O. Box 1450 Alexandria, Virginia 22313-1450

### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

EDUTATES PATENT AND THE

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the references listed on the attached Form PTO-1449 be considered by the Examiner and made of record.

This Supplemental Information Disclosure Statement is not to be considered as a representation that a search has been made or that no other material information as defined under 37 C.F.R. § 1.56(a) exists. Each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. (EPC-85.79973, international search report dated February 10, 2004).

The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 13-0010 (IO-1002US).

STORY TANK

Respectfully submitted,

Dated: March 10, 2004

Todd A. Bynum, Reg. 6. 39,488

MADAN, MOSSMAN & SRIRAM, P.C.

2603 Augusta, Suite 700 Houston, Texas 77057

Telephone: (713) 266-1130 Facsimile: (713) 266-8510

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)** 

I hereby certify that this paper, along with any referred to as being attached or enclosed, is being forwarded to Commissioner for Patents, P. O. Box 1450, Alexandria, Virginia 22313-1450, via the United Tates Postal Service, First Class Mail prepaid on the 10th day of March, 2004.

Beth Pearson-Naul

ો

SHEET	ı	OF	

EO	DIA	_ 1	449



# SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO.	SERIAL NO.	
IO-1002US	09/867,286	

**APPLICANT** 

Robert Ried et al.

(Use several sheets if necessary)

FILING DATE
May 29, 2001

GROUP / CONFIRMATION

2856 / 6239

### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	4,993,143	02/91	Sidner et al.	29	621.1	03/90
3	AB	5,616,514	04/97 .	Muchow et al.	438	50	06/95
	AC	6,041,653	03/00	Ichikawa et al.	73	514.32	12/97
	AD						
	AE					:	
	AF						
	AG						
			FO	REIGN PATENT DOCUMEN	NTS		

	DOCUMENT NUMBER	PUBL. DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
 АН	EP1043770A1	11.10.00	EPO			X
ΑI	EP0863392A1	09.09.98	EPO			X
AJ						

## OTHER DISCLOSURES (Including Author, Title, Date, Pertinent Pages of Publication, Etc.)

AK	Erno H. Klaassen et al.; Silicon fusion bonding and deep reactive ion etching: a new technology for microstructures, Sensors and Actuators, A52 (1996), XP 453098, pp. 132-139
AL	C. H. Yun et al.; SOI on Buried Cavity Patterns Using Ion-Cut Layer Transfer, Proceedings 1998 IEEE International SOI Conference, Oct. 1998, p. 165.
AM	

EXAMINER			DATE CONSIDERED	

\*EXAMINER:

Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line though citation if not in conformance and not considered. Include copy of this form with next comment to applicant